L Number	Hits	Search Text	DB	Time stamp
1	189	156/345.21 156/345.22 156/345.17	USPAT	2003/12/17 09:23
2	0	brown-charlotte.xa.	USPAT	2003/12/17 09:23
3	236	brown-c$.xa.	USPAT	2003/12/17 09:32
4	790	134/113	USPAT	2003/12/17 10:07
5	97	("integrated bevel" "ibc") and (wafer semiconductor wafer)	USPAT	2003/12/17 10:20
6	1498	"edge bead"	USPAT	2003/12/17 10:20
7	0	"edge bead" not ((156/345.21 156/345.22 156/345.17) brown-c$.xa. 134/113 (("integrated bevel" "ibc") and (wafer semiconductor wafer)) "edge bead")	USPAT	2003/12/17 10:21
8	1495	"edge bead" not ((156/345.21 156/345.22 156/345.17) brown-c$.xa. 134/113 (("integrated bevel" "ibc") and (wafer semiconductor wafer)))	USPAT	2003/12/17 10:21
9	227	("edge bead" not ((156/345.21 156/345.22 156/345.17) brown-c$.xa. 134/113 (("integrated bevel" "ibc") and (wafer semiconductor wafer)))) and (etch$3)	USPAT	2003/12/17 10:31
10	169	"edge bead" not ((156/345.21 156/345.22 156/345.17) brown-c$.xa. 134/113 (("integrated bevel" "ibc") and (wafer semiconductor wafer)))) and (rins$3)	USPAT	2003/12/17 10:32
11	53	(("edge bead" not ((156/345.21 156/345.22 156/345.17) brown-c$.xa. 134/113 (("integrated bevel" "ibc") and (wafer semiconductor wafer)))) and (rins$3)) not (("edge bead" not ((156/345.21 156/345.22 156/345.17) brown-c$.xa. 134/113 (("integrated bevel" "ibc") and (wafer semiconductor wafer)))) and (etch$3))	USPAT	2003/12/17 10:32